PATENT COOPERATION TREATY

From the INTERNATIONAL SEARCHING AUTHORITY To: NOTIFICATION OF TRANSMITTAL OF MORIMOTO, Yoshihiro THE INTERNATIONAL SEARCH REPORT All Nippon Airways (Nishi-Hommachi) OR THE DECLARATION 4th floor, 10-10, Nishi-Hommachi 1-chome Nishi-ku, Osaka shik Osaka 550-0005 (PCT Rule 44.1) JAPAN AFR - 1.2002 森本 Date of mailing (day/month/year) 02/04/2002 Applicant's or agent's file reference FOR FURTHER ACTION PCT3144 See paragraphs 1 and 4 below international application No. International filing date (day/month/year) PCT/JP 01/06230 18/07/2001 Annikant MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD. 1. X The applicant is hereby notified that the international Search Report has been established and is transmitted herewith. Filing of amendments and statement under Article 19: The applicant is entitled, if he so wishes, to amend the claims of the International Application (see Fule 46): When? The time limit for filing such amendments is normally 2 months from the date of transmittal of the International Search Report; however, for more details, see the notes on the accompanying sheet. Where? Directly to the International Bureau of WIPO 34, chemin des Colombettes 1211 Geneva 20, Switzerland Fascimile No.: (41–22) 740,14,35 For more detailed instructions, see the notes on the accompanying sheet. 2. The applicant is hereby notified that no International Search Report will be established and that the declaration under Article 17(2)(a) to that effect is transmitted herewith. 3. With regard to the protest against payment of (an) additional fee(s) under Rule 40.2, the applicant is notified that: the protest together with the decision thereon has been transmitted to the international Bureau together with the applicant's request to forward the texts of both the protest and the decision thereon to the designated Offices. no decision has been made yet on the protest; the applicant will be notified as soon as a decision is made. 4. Further action(s): The applicant is reminded of the following:

Shortly after 18 months from the priority date, the international application will be published by the International Bureau. If the applicant wishes to avoid or postpone publication, a notice of withdrawal of the international application, or of the priority claim, must reach the International Bureau as provided in Rules 90bis 1 and 90bis 3, respectively, before the completion of the technical preparations for International publications.

Within 19 months from the priority date, a demand for international preliminary examination must be filed if the applicant wishes to postpone the entry into the national phase until 30 months from the priority date (in some Offices even later).

Within 20 months from the priority date, the applicant must perform the prescribed acts for entry into the national phase before all designated Offices which have not been elected in the demand or in a later election within 19 months from the priority date or could not be elected because they are not bound by Chapter II.

Name and mailing address of the International Searching Authority
European Patent Office, P.B. 5818 Patentisan 2
Name 280 HV Illiswijk
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Authorized officer

Gennaro Cappiello

Form PCT/ISA/220 (July 1998)

PATENT COOPERATION TREATY

PCT

INTERNATIONAL SEARCH REPORT

(PCT Article 18 and Rules 43 and 44)

Applicants or agents file reference	(Form PCT/ISA/2	of Transmittal of international Search Report (20) as well as, where applicable, item 5 below.
PCT3144	ACTION	<u> </u>
International application No.	International filing date (day/month/year)	(Earliest) Priority Date (day/month/year)
PCT/JP 01/06230	18/07/2001	21/07/2000
Applicant		
MATCHCUTTA ELECTRIC TURNS	TDT44 00 1 TD	
MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD.		
This international Search Report has been according to Article 18. A copy is being to This international Search Report consists		nority and is transmitted to the applicant
	a copy of each prior art document cited in this	report.
1. Basis of the report		
 With regard to the language, the language in which it was filed, uni- 	international search was carried out on the bar ess otherwise indicated under this item.	is of the International application in the
the international search was carried out on the basis of a translation of the international application furnished to this Authority (Rule 23.1(b)).		
 With regard to any nucleotide and was carried out on the basis of the 	d/or amino acid sequence disclosed in the in sequence listing:	ternational application, the international search
contained in the international application in written form.		
flied together with the international application in computer readable form. furnished subsequently to this Authority in written form.		
furnished subsequently to this Authority in computer readble form.		
	sequently furnished written sequence listing d	bes not go beyond the disclosure in the
remark to the second se		identical to the written sequence listing has been
2. Certain claims were four	nd unsearchable (See Box i).	
3. Unity of invention is lack	ing (see Box il).	
4. With regard to the title.		
X the text is approved as sut	omitted by the applicant.	
the text has been establish	ed by this Authority to read as follows:	
5. With regard to the abstract,		
the lext is approved as sub		
the text has been establish within one month from the	ed, according to Rule 38.2(b), by this Authority date of mailing of this international search rep	as it appears in Box III. The applicant may, ort, submit comments to this Authority.
6. The figure of the drawings to be published	shed with the abstract is Figure No.	1
X as suggested by the applic	ant.	None of the figures.
because the applicant faile		
because this figure better of	haracterizes the invention.	
orm PCT/ISA/210 (first sheet) (July 1998)		

International application No.

INTERNATIONAL SEARCH REPORT

PCT/JP 01/06230

Box III TEXT OF THE ABSTRACT (Continuation of Item 5 of the first sheet)

According to the present invention, when a semiconductor element (7) having protruding electrodes(5) formed thereon is connected to a circuit board (1) via conductive resin(6), stable connection is made even when an electrode pitch is small on the semiconductor element (7). On semiconductor element package regions on the circuit board(1), a paste electrode material(2) containing photopolymerizable materials is printed to form a film having a prescribed thickness, and this electrode material film (2) is baked after exposure and development thereof so as to obtain circuit electrode(4)s having edges warped in a direction of going apart from the circuit board(1) surface. Then, the protruding electrodes(5) and the concave surfaces of the circuit electrodes (4) are brought in abutment with each other and connected via the conductive resin(6) which surrounds the abutments between the respective electrodes (4,5) and is held on the concave surfaces of the circuit electrodes (4). With this arrangement, the concave surfaces of the circuit electrodes(4) act as saucers and prevent the conductive resin(6) from being squeezed out, thereby eliminating possible occurrence of short circuits.